



# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/234,233  
Filing Date ..... January 20, 1999  
Inventor ..... Weimin Li et al  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2818  
Examiner ..... D. Vu  
Attorney's Docket No. .... MI22-1035  
Title: Semiconductor Processing Methods

## PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Box RCE  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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28/ Pre-  
Response  
R. Staley  
REC'D - 31-12-2002  
RECEIVED  
DEC - 14 2002  
T C 2800 MAIL ROOM

## REMARKS

This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to permit consideration of a Supplemental Information Disclosure Statement.

No new matter is being presented in this application.

A telephonic interview is requested in the event that the next office action is one other than a Notice of Allowance. The undersigned is available during normal business hours (Pacific Time Zone).

Respectfully submitted,

Dated: 26 Nov 2002

By:

  
James E. Lake  
Reg. No. 44,854